

Notice of References Cited	Application/Control No. 10/553,083		Applicant(s)/Patent Under Reexamination HOJO ET AL.	
	Examiner Cynthia Hamilton		Art Unit 1752	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Pasini et al , SPIE Conference on Advances in Resist TEchnology and processing XVI, Santa Clara, CA, March 1999, SPIE Vo. 3676 pages 94-101
	V	Hein et al , Advances in Rist TEchnology and Processing XVIII, Houlihan, ed, Proceedings of SPIE Vol. 4345 (2001 no month) pages 439-447.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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